

Website: https://smallbusiness.ornl.gov

Request for Proposal - Ion Source High Voltage (HV) Cabinets

Category: Industrial Equipment Small Business Set-Aside: Yes Estimated Value: \$10M NAICS Code: 334516 Expected Issue Date: May 2024 Expected Award Date: July 2024 Contact Name: Terri Cleveland Contact Email: clevelandtd@ornl.gov Long Description

UT-Battelle, LLC (the Company) is seeking proposals for procurement of two (2) assembled Ion Source High Voltage (HV) Cabinets, with a option for an additional twenty (20) cabinets. The cabinets will be delivered to Oak Ridge National Laboratory (ORNL) in support of a DOE funded research and development program. The scope of work includes refinement of final design for manufacturing, procurement of commercially available components, fabrication, assembly, inspections, testing, storage (as needed), and delivery of the Ion Source HV Cabinets according to Company provided design drawings, assembly drawings, solid models, Specifications, and Statement(s) of Work.

Attachment A - Ion Source High Voltage (HV) Cabinet EOI Overview.pdf